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Serial Number: 10708509

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US 20050284815 A1	20051229	MEDICAL TREATMENT SYSTEM AND METHOD	210/645	210/646; 210/742; 604/4.01; 604/65	Sparks, Douglas Ray et al.
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US 20050126304 A1	20050616	FLUID INFUSION METHOD AND SYSTEM THEREFOR	73/861.05		Sparks, Douglas Ray et al.
US 20050065589 A1	20050324	Method and anchor for medical implant placement, and method of anchor manufacture	607/126		Schneider, Richard Lee et al.
US 20040255648 A1	20041223	RESONANT TUBE VISCOSITY SENSING DEVICE	73/54.41		Sparks, Douglas Ray

US 20040171983 A1	20040902	FLUID DELIVERY SYSTEM AND SENSING UNIT THEREFOR	604/65	128/DIG.13	Sparks, Douglas R. et al.
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